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OCT 2'8 2005
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the proprietion of:

OSUDA, et al.

Serial No.: 10/675,939

Filed: October 2, 2003

Group Art Unit: 1724

Examiner: Robert J. Popovics

P.T.O. Confirmation No.: 5925

For: METHOD AND APPARATUS FOR REUSE OF ABRASIVE FLUID USED IN THE

MANUFACTURE OF SEMICONDUCTORS

<u>PURSUANT TO 37 CFR 1.97(b)</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 28, 2005

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

Documents AF-AG were contained in the Korean Office Action dated September 16, 2005. A copy of the Office Action is also enclosed.

No fee is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution

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of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

Donald W. Hanson Attorney for Applicants Reg. No. 27,133

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Enclosures: PTO1449, Office Action; 2 References



INFORMATION
DISCLOSURE
CITATION
PTO-1449

Atty. Docker Manager A	Serial No. 10/675,939
Applicant(s): Osuda et al	Confirmation No. 5925
Filing Date: October 2, 2003	Group Art Unit: 1724

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Sub class	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
 AF	09-504223	4/28/97	JP	yes, abstract
 AG	1998-063539	10/7/98	KR	yes, abstract
 АН				
 Al				
 AJ				

OTHER DOCUMENTS

	AK AL	Korean Office Action dated 9/16/05	
Examiner Date Considered			